



BTW

PATENT  
Customer No. 22,852  
Attorney Docket No. 04329.3157

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: )  
)  
Hajime NAGANO et al. ) Group Art Unit: 2818  
)  
Application No.: 10/675,950 ) Examiner: Le, Thao P.  
)  
Filed: October 2, 2003 ) Confirmation No. 5922  
)  
For: SEMICONDUCTOR DEVICE AND )  
METHOD FOR MANUFACTURING )  
PARTIAL SOI SUBSTRATES )

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**RESPONSE TO RESTRICTION REQUIREMENT**

In the Restriction Requirement mailed March 1, 2005, with a period for response extending to April 1, 2005, the Examiner required restriction under 35 U.S.C. § 121 between Group I (claims 1-7) and Group II (claims 8-20). Applicants elect to prosecute Group I, claims 1-7, characterized by the Examiner as drawn to a semiconductor device, without traverse.

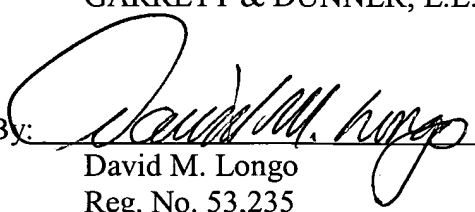
Please grant any extensions of time required to enter this response and charge any additional required fees to our deposit account 06-0916.

Respectfully submitted,

FINNEGAN, HENDERSON, FARABOW,  
GARRETT & DUNNER, L.L.P.

Dated: March 22, 2005

By:

  
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